



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of) Art Unit: 2879
Hisashi OHTANI et al.) Examiner: R. Booth
Serial No. 09/908,727)
Filed: July 20, 2001)
For: SEMICONDUCTOR DEVICE)
AND METHOD OF MANUFACTURING)
THE SAME)

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with The United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on April 17, 2003.

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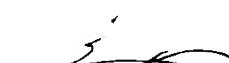
CORRECTION TO INFORMATION DISCLOSURE STATEMENT

Honorable Commissioner of Patents
Washington, D.C. 20231

Sir:

The Information Disclosure Statement filed July 20, 2001 included inadvertent typographical errors on the Form 1449 submitted therewith. Specifically, U.S. Patent 5,923,962 was incorrectly listed as 5,932,962, and an Abstract for JP 07-130652 is believed to be of record rather than a full English translation as listed on the 1449. A corrected Form 1449 is submitted herewith with respect to these references and it is requested that the Examiner line through the previously listed incorrect references and initial the attached 1449 evidencing consideration of the corrected documents.

Respectfully submitted,


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